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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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11-7-01

In re Application of: )  
CHIAKI TERASAWA, ET AL. ) Examiner: Unassigned  
Application No.: 09/784,021 ) Group Art Unit: Unassigned  
Filed: February 16, 2001 )  
For: PROJECTION OPTICAL SYSTEM ) April 24, 2001  
AND PROJECTION EXPOSURE )  
APPARATUS )

Commissioner for Patents  
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Further to the Information Disclosure Statement filed on March 26, 2001, and to comply with the duty of disclosure under 37 CFR 1.56 and in accordance with the practice under 37 CFR 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 Form. A copy of the listed document is enclosed.

The Japanese Laid-Open Patent Application No. 10-079345 is discussed on page 1 of the specification and discusses a projection optical system.

Applicants request that the above information be considered by the Examiner and that an initialed copy of the enclosed PTO-1449 Form be returned indicating that such information has been considered.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated herewith.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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